

11/21/03

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Form PTO-1449 (Rev. 7-80)	U.S. Department of Commerce Patent & Trademark Office	ATTY. DOCKET NO. 9-14774-1US-1-1	SERIAL NO. <u>10/717460</u> Not yet assigned.
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT DAVID F. SKOLL et al.	
		FILING DATE: <u>Concurrently herewith.</u>	GROUP <u>2825</u>
		<u>11-21-03</u>	

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
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PD	AR	Article: "Chip Scanner System High Resolution SEM Image Capture and conversion from image to GDS-11 layout, George Lanzarotta, Raith USA, Inc., November 1999
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Examiner <u>PAUL DINH</u>	Date considered <u>4/25/05</u>
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	